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December 7, 2004

TO (FIRM): United States Patent And Trademark Office, Group Art Unit: 2653
ATTN: Examiner: Kim Kwuk Chu

FAX NO.: 703-872-9306

TELEPHONE:

FROM: James G. McEwen

Re: U.S. Patent Application
Serial No.: 09/898,201
For: OPTICAL PICKUP WITH IMPROVED COLLIMATING LENS FOR USE WITH
LONG AND SHORT WAVELENGTH LASER BEAMS *
Inventor: Tae-kyung KIM, et al.
Our Docket: 1293.1144

NO. OF PAGES (Including this Cover Sheet) 6

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COMMENTS:

RESPONSE AND REQUEST FOR RECONSIDERATION
UNDER 37 C.F.R. §1.116
**** EXPEDITED PROCEDURE ****

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Docket No. 1293.1144

**RESPONSE AND REQUEST FOR RECONSIDERATION
UNDER 37 C.F.R. §1.116**

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Tae-kyung KIM, et al.

Application No.: 09/698,201

Group Art Unit: 2653

Confirmation No. 6730

Filed: October 30, 2000

Examiner: Kim Kwuk Chu

For: **OPTICAL PICKUP WITH IMPROVED COLLIMATING LENS FOR USE WITH LONG
AND SHORT WAVELENGTH LASER BEAMS**

MAIL STOP AF
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

This is responsive to the Final Office Action mailed September 15, 2004, having a shortened period for response set to expire on December 15, 2004.

The following remarks are respectfully submitted.